



EXPEDITED PROCEDURE
Examining Group Number 2800

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amendment

D.P.

6/7/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	David C. Chu	Examiner:	Demetrius R. Pretlow
Serial No.:	10/052,673	Group Art Unit:	2863
Filed:	January 17, 2002	Docket No.:	10020043-1 (A310.119.101)
Due Date:	May 31, 2004		
Title:	SYSTEM AND METHOD FOR INTERFEROMETER NON-LINEARITY COMPENSATION		

RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is responsive to the Final Office Action mailed March 31, 2004.